



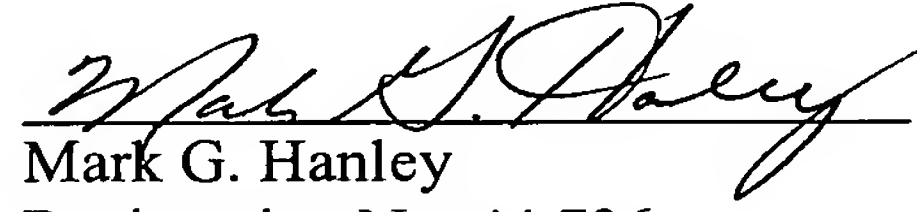
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Gyung-Su Cho
U.S. Serial No. : 10/676,645
Filed : October 1, 2003
Title : "Semiconductor Device
and Fabrication Method
Thereof"
Art Unit : 2811
Examiner : Thomas J. Magee

) I hereby certify that this paper (and/or
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)

) **Dated: December 22, 2004**
)

) 
) Mark G. Hanley
) Registration No. 44,736
) Attorney for Applicant
)

RESPONSE TO THE OFFICE ACTION DATED NOVEMBER 5, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office action dated November 5, 2004, please enter the
following amendments and consider the following remarks:

Amendments begin on page 2 of this paper.

Remarks begin on page 4 of this paper.